

Notice of References Cited	Application/Control No. 10/695,955		Applicant(s)/Patent Under Reexamination KIKUCHI ET AL.	
	Examiner Thomas D. Alunkal		Art Unit 2633	Page 1 of 1

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NON-PATENT DOCUMENTS

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	U	Ward et al., Lens Aberration Correction by Holography, APPLIED OPTICS/Vol. 10, No.4/April 1971, p. 896-900
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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